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According to the project "Strategy of development of electronic branch for the period till 2025" till 2019 it is planned on the basis of the international standards IPC and МЭК "to Provide lobbying of the Russian technologies as the international standards...".
The solution of a problem of maintenance of the set mode of the soldering has the big practical value for improvement of quality brazed connections of electronic devices.
In article the question of influence of sharpening of a soldering core on temperature of the contact soldering is considered.
Keywords: the device, quality, a soldering core, a contact soldering, temperature

This paper describes the technology for fabrication of high-Q micromachined silicon resonators using SOI-wafer as material. The technology utilizes only one anodic bonding step and one soda-lime glass with recesses formed on it by wet etching. The SOI-wafer and the glass are batch processed, anodic bonding is performed at the back-end of the processing. A micromachined resonator is fabricated using the developed technology. The integrity of the whole structure is tested, good agreement of measured and calculated parameters is shown. The potential of the technology is discussed.
Keywords: microfabrication, silicon high-Q resonators, wafer level encapsulation

Piezoelectric permanent magnetic field sensor using a planar bimorph lead zirconate titanale structure with additional current carrying conductor is described. The sensor operation is based on combination of the Ampere force and the piezoelectric effect. Sensitivity of the sensor was 10 equal to 10 W(A · kOe) and minimal detecting field was 0,1 Oe at the bending resonance frequency of the structure.
Keywords: magnetic field sensor, bimorph structure, piezoelectric, lead zirconate titanate

Different circuits of microelectromechanical energy converter are analyzed and compared. The converter allows to periodically recover the energy taken from the primary source, and, therefore, to operate as microelectromechanical electrical energy recuperator. The analytical expressions for evaluation of the charge recuperated to the primary energy source are presented.
Keywords: energy harvesting, energy recovery, microelectromechanical energy recuperator, electrostatic mechanical-to-electrical energy converter

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Дизайнер *Т. Н. Погорелова.* Технический редактор *Е. М. Патрушева.* Корректор *Е. В. Комиссарова*

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